



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/763,578 Confirmation No.: 4912  
Applicant : BOWER, ROBERT W.  
Title : STRUCTURES, MATERIALS AND METHODS FOR  
FABRICATION OF NANOSTRUCTURES BY TRANSPOSED  
SPLIT OF ION CUT MATERIALS  
Filed : 01/21/2004  
TC/A.U. : 2823  
Examiner : JEFFERSON, QUOVAUNDA  
Docket No. : BOW5075.14A1  
Cust. No. : 8156

Certificate of Mailing (37 CFR 1.8)

**Mail Stop AMENDMENT**  
**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22213-1450**

I hereby certify that this paper is being deposited with the United States Postal Service with sufficient postage for first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" on the dated indicated below.

\_\_\_\_\_  
John P. O'Banion  
(name)  
\_\_\_\_\_  
(signature)  
\_\_\_\_\_  
7/14/06  
(date)

**AMENDMENT**

Dear Sir:

In response to the Office Action mailed on 02/14/2006, please amend the above-identified U.S. patent application as follows. A Petition for Extension of Time for two months is being submitted herewith.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 20 of this paper.